

NAMIFAB UGENT

dr. ir. Thomas Vervust

OVERVIEW

- Introducing NaMiFab UGent
- Use case examples
- NaMiFab expertise
- Collaboration with NaMiFab
- Contact information

INTRODUCING NAMIFAB UGENT

NaMiFab UGent:

- Is an **expertise center for Nano-and Microfabrication.**
- We structure and combine different materials at nano- and microscale.
- We design and fabricate various components and systems.

INTRODUCING NAMIFAB UGENT

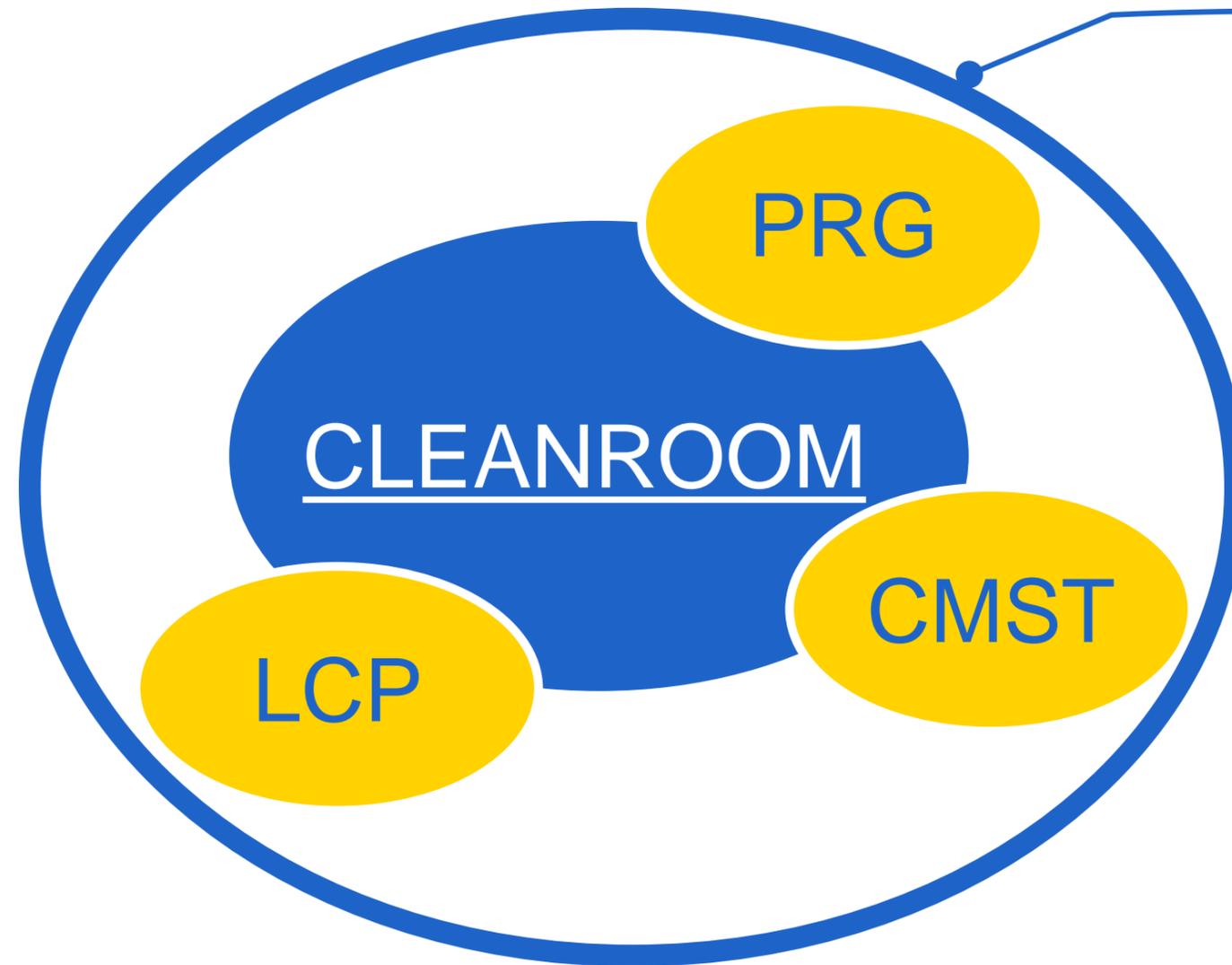


Cleanroom
Tech Lane Ghent
Science Park - Campus A

Technologiepark-Zwijnaarde 914 – 926
9052 Ghent

INTRODUCING NAMIFAB UGENT

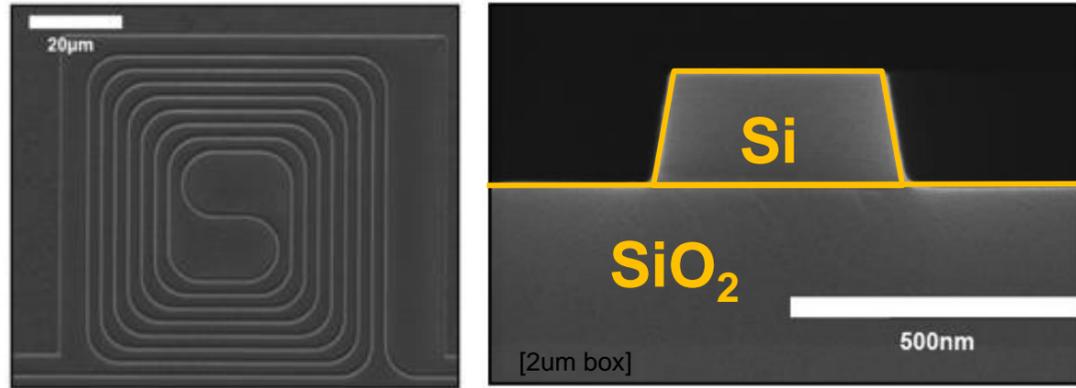
NaMiFab UGent



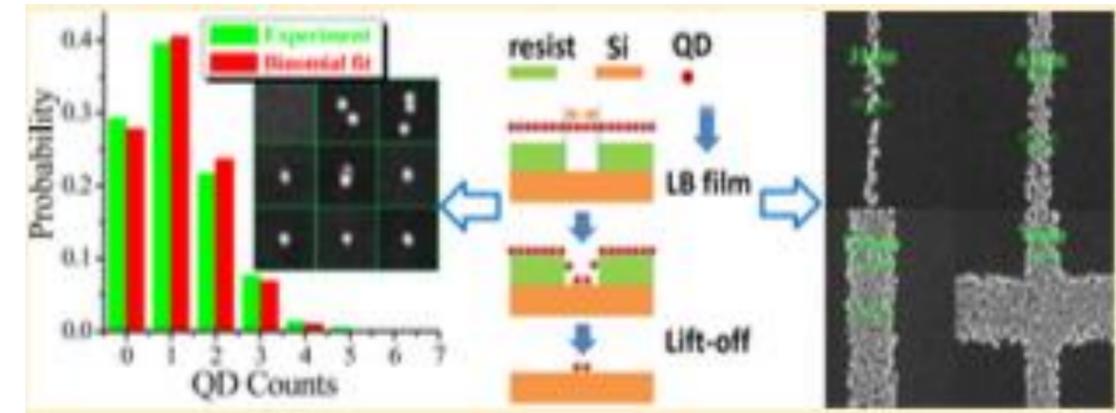
Expertise Centre for Nano- and Microfabrication

PRG - TECHNOLOGY PLATFORMS

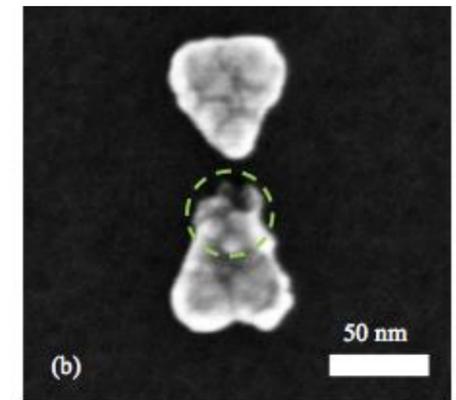
Silicon & SiN Waveguides



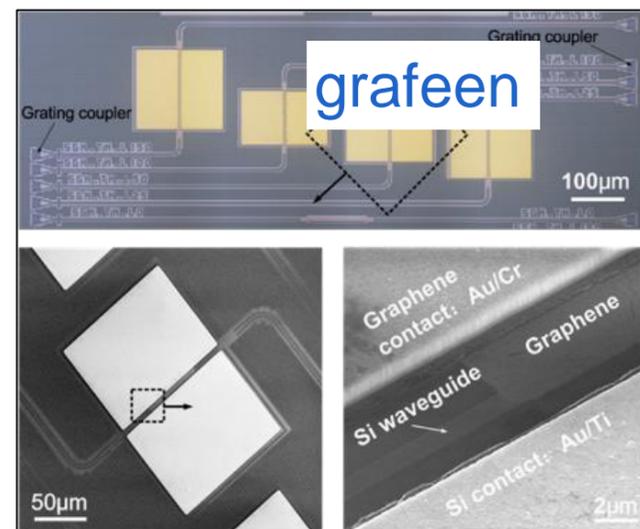
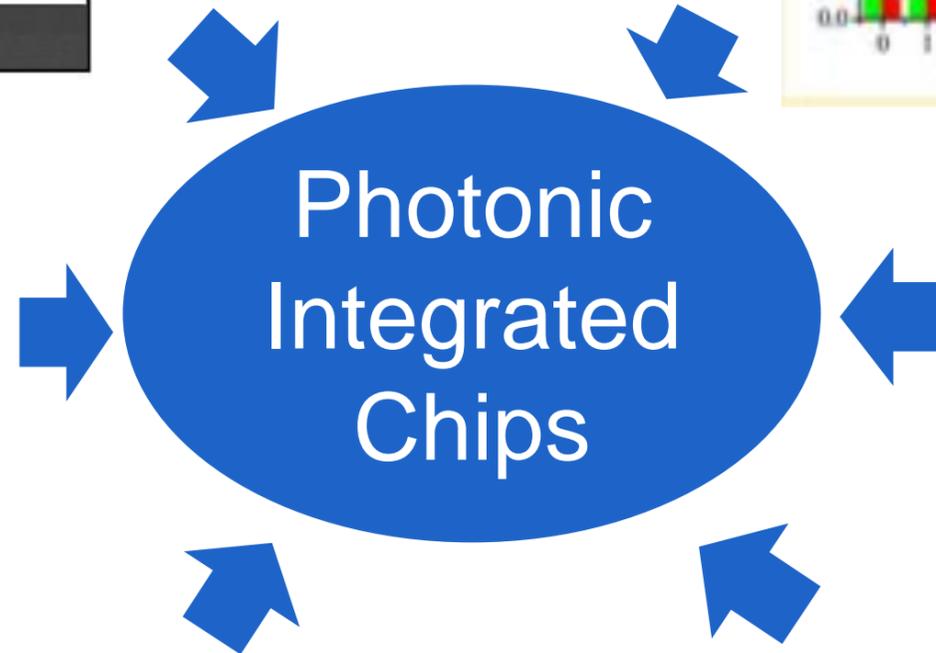
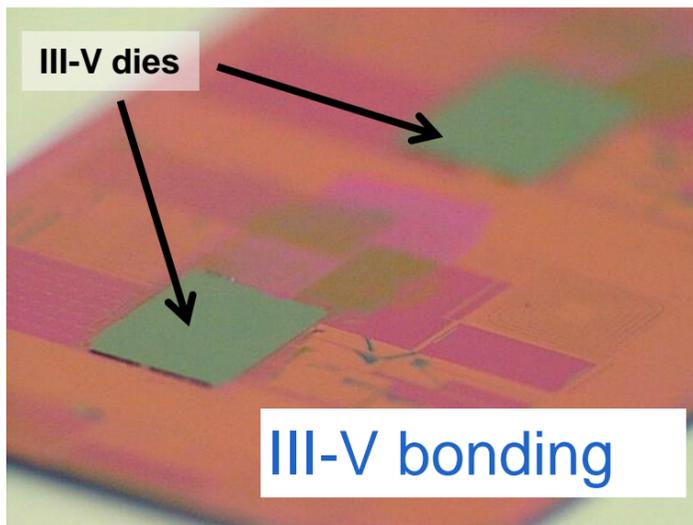
High resolution imaging (SEM, FIB)



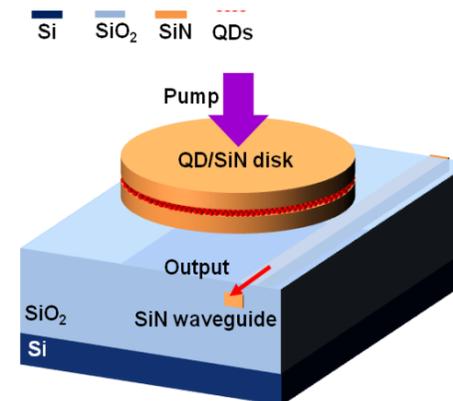
High resolution patterning (EBEAM)



Integration with new materials

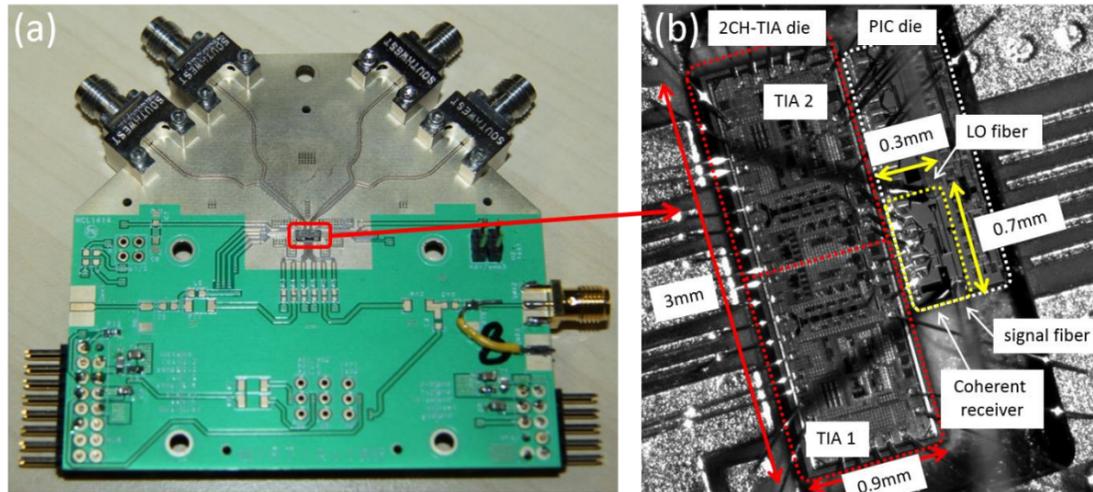


Colloidal QDOTS

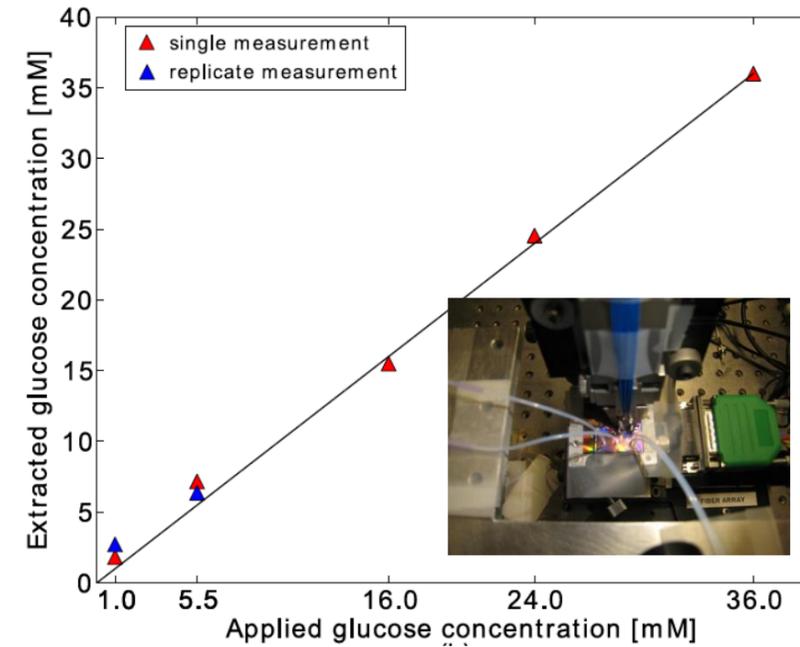


High resolution structures

PRG - APPLICATION EXAMPLES

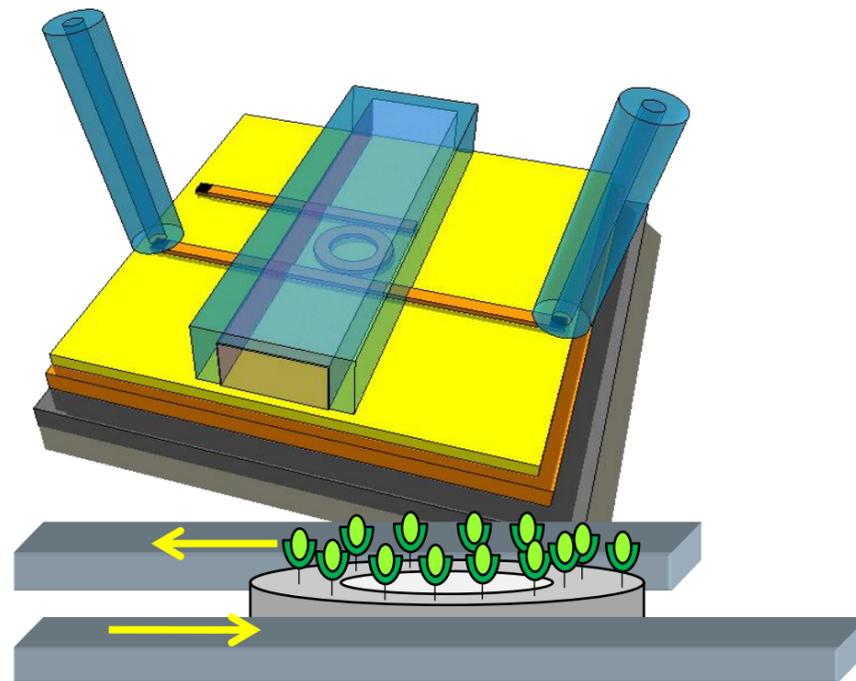


High-speed opto-electronic transceivers



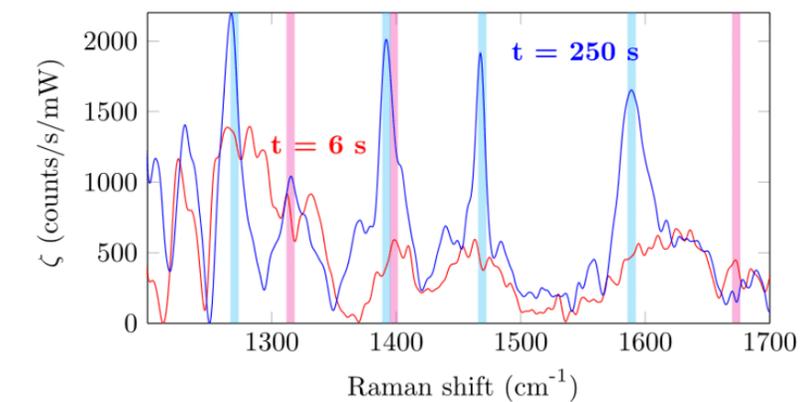
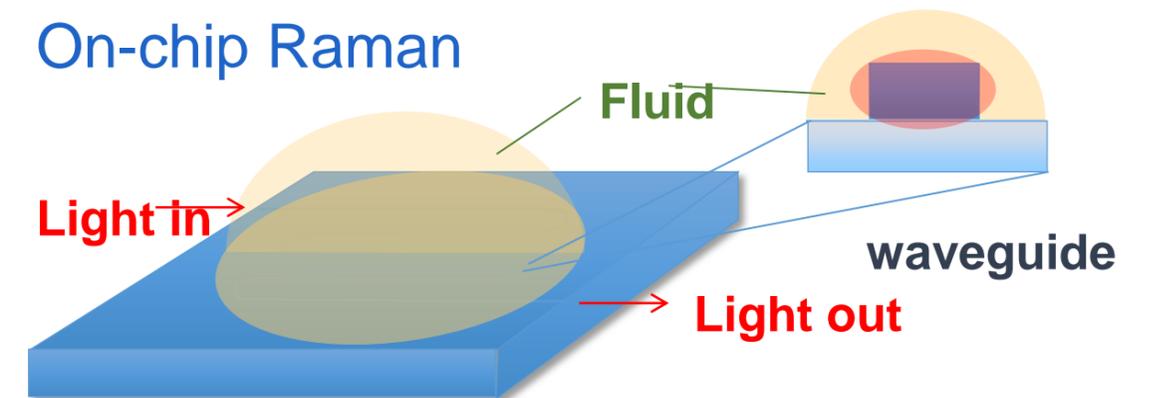
On-chip spectroscopy

- Glucose detection
- Gas-sensing
- ...

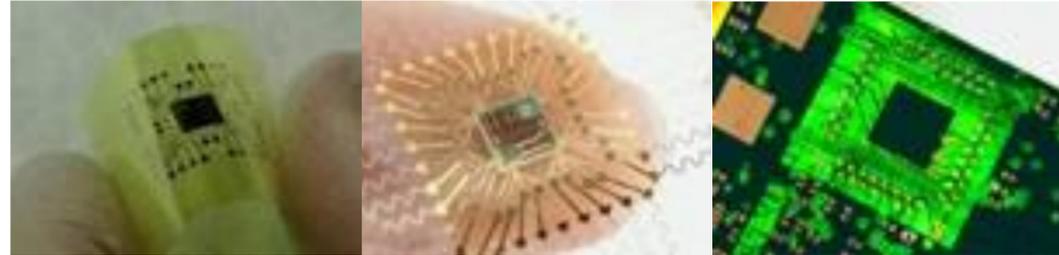


Biosensing (e.g. detection of Tuberculosis)

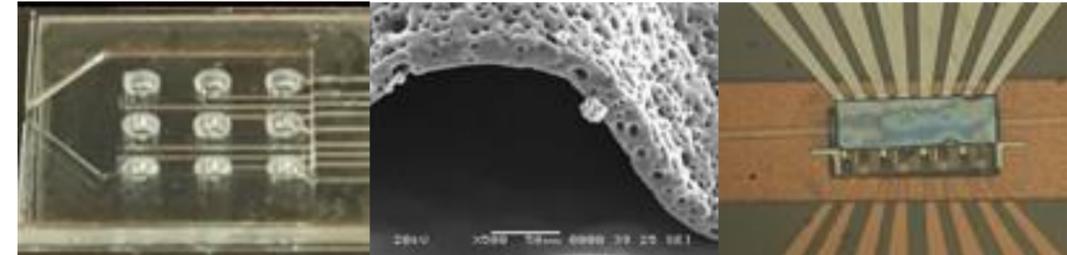
On-chip Raman



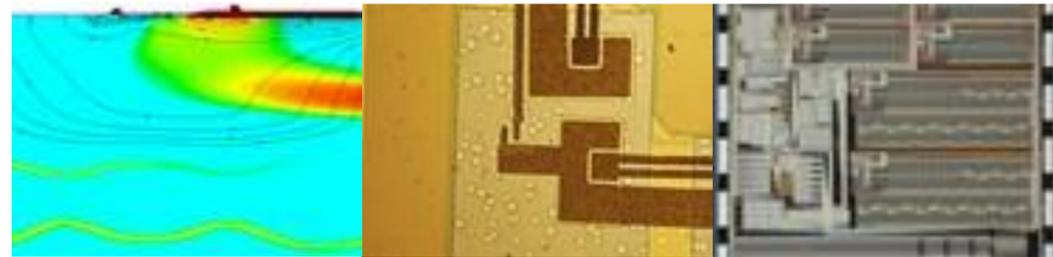
CMST - TECHNOLOGY PLATFORMS



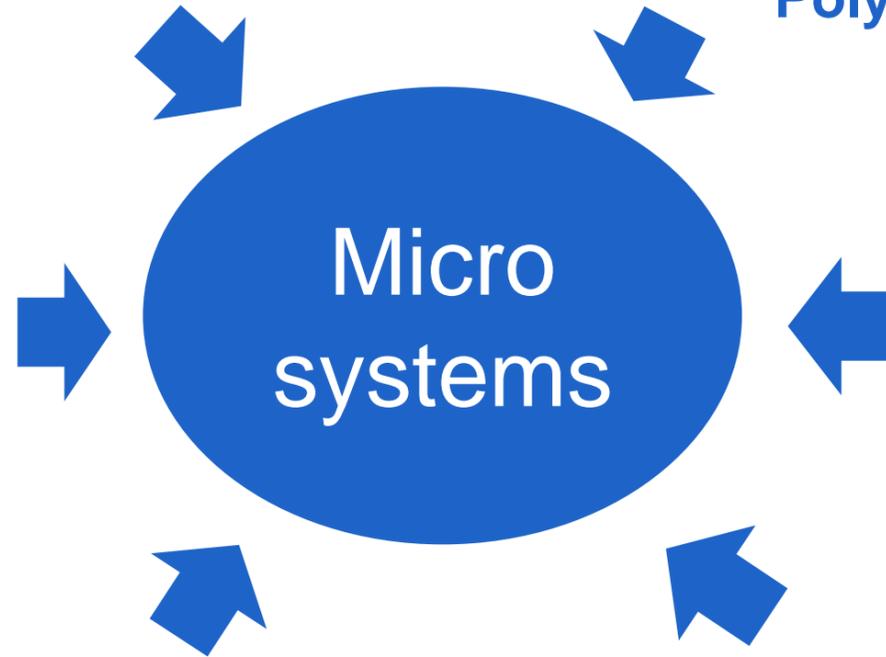
Electronic packaging



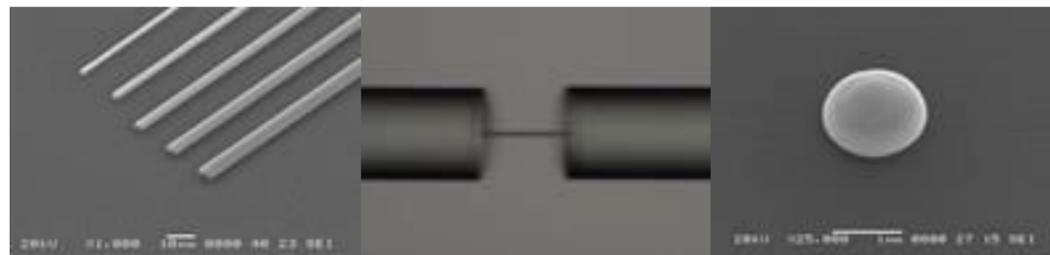
Polymer processing - microfluidics



ASIC design



Stretchable interconnect



Polymer photonics and laser technology

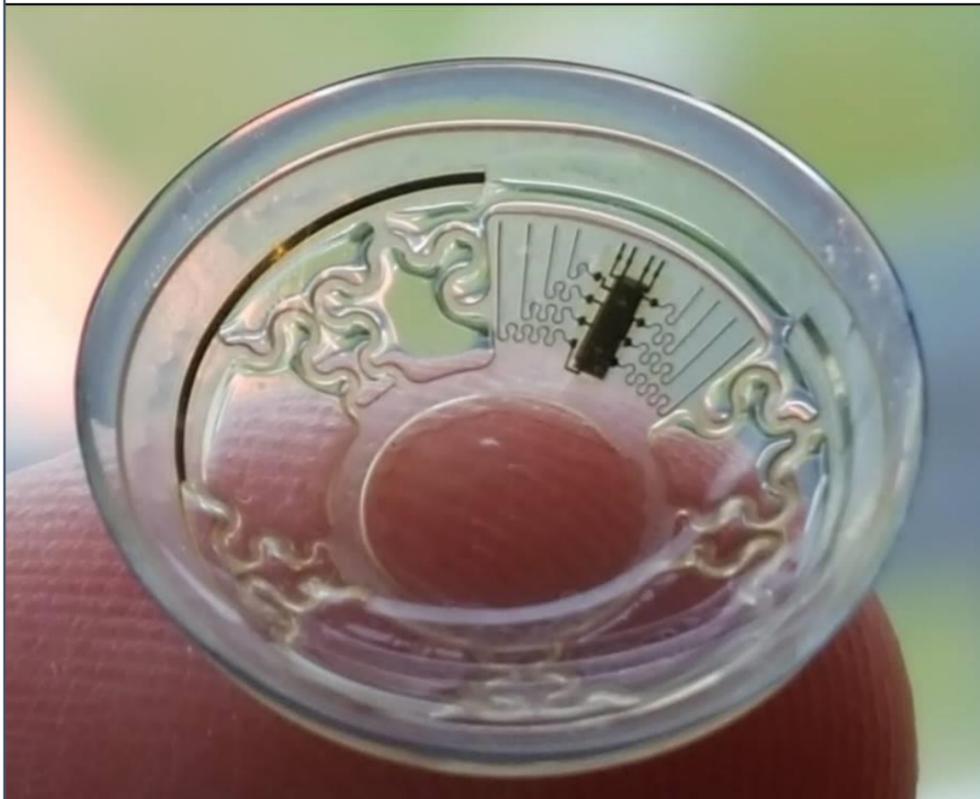


Electro-optical devices and displays

CMST - APPLICATION EXAMPLES

Smart contact lens

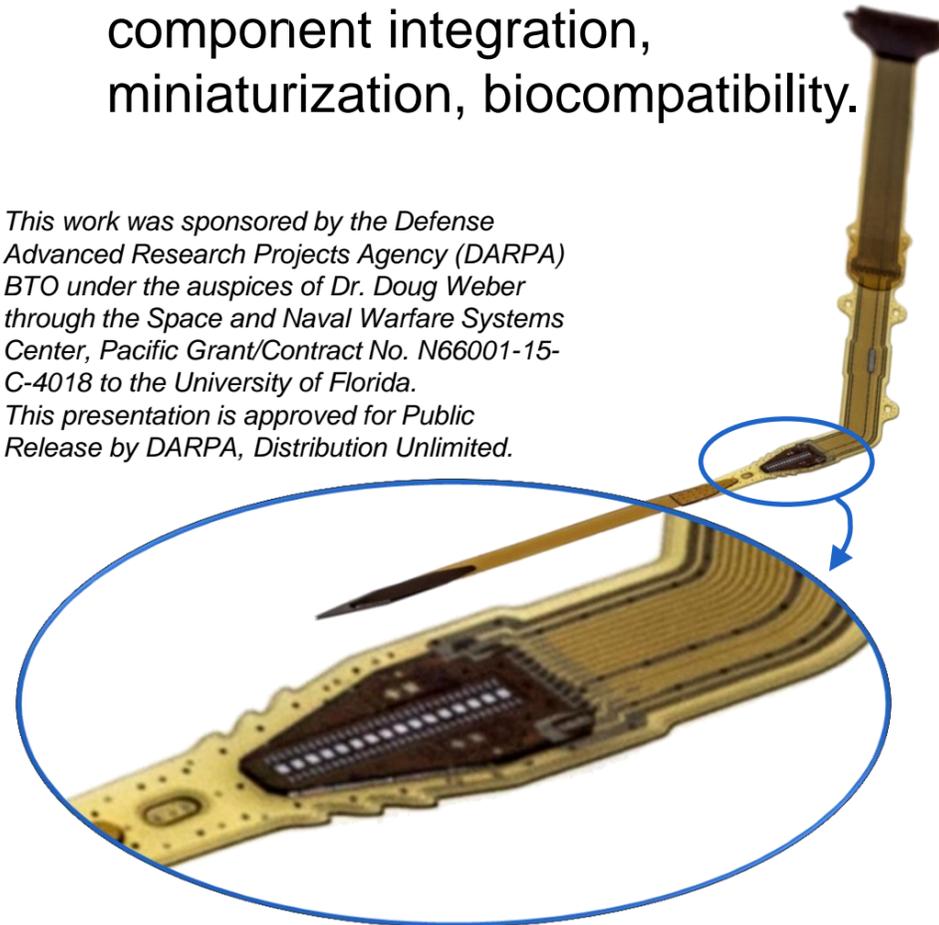
- Electronic platform with sensors, controller, communication, electro-optic switching, battery...
- Applications: artificial iris, presbyopia correction, sensing..



Implantable PNS probe

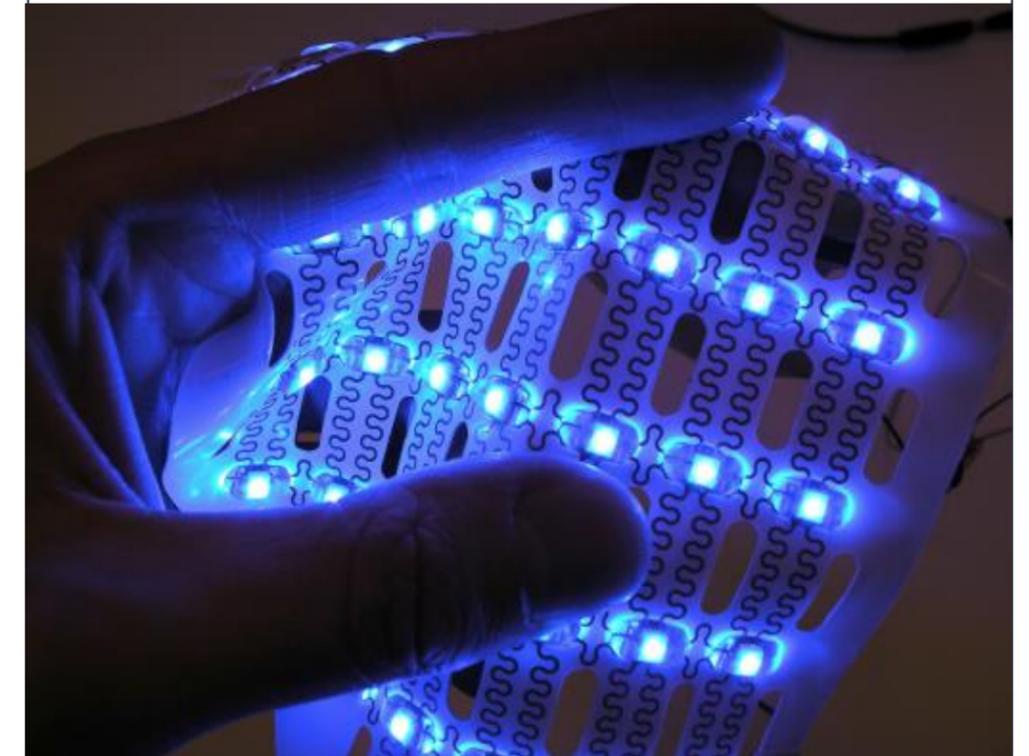
- Implantable peripheral recording and stimulation system for closed-loop sensory control of prostheses
- Technology for electronic component integration, miniaturization, biocompatibility.

This work was sponsored by the Defense Advanced Research Projects Agency (DARPA) BTO under the auspices of Dr. Doug Weber through the Space and Naval Warfare Systems Center, Pacific Grant/Contract No. N66001-15-C-4018 to the University of Florida. This presentation is approved for Public Release by DARPA, Distribution Unlimited.



Stretchable light source

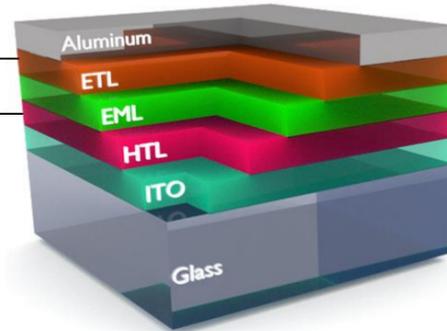
- Technology for stretchable interconnections in polymer and component mounting
- Applications: luminaires, RSI pain relief bandage...



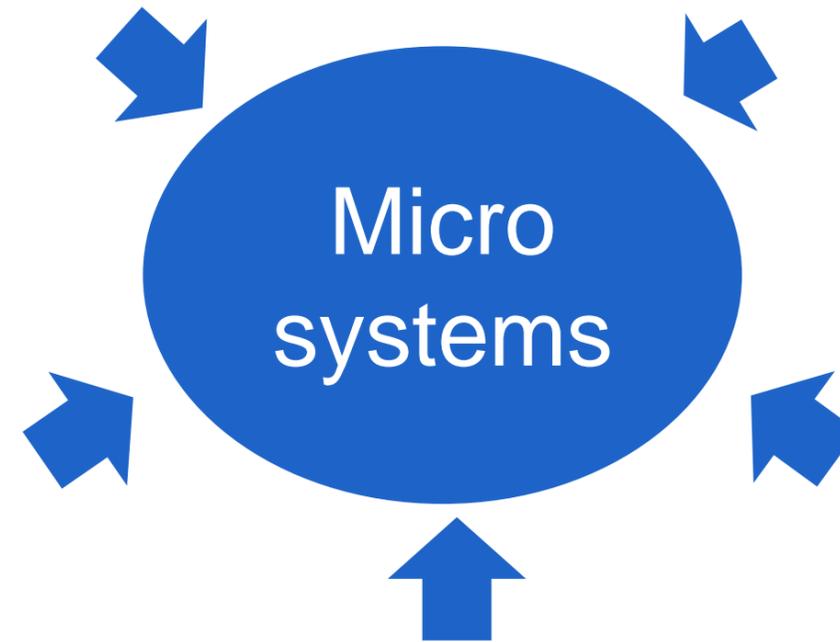
LCP - TECHNOLOGY PLATFORMS



Organic layer deposition and OLEDs



Atomic layer deposition



LCD assembly

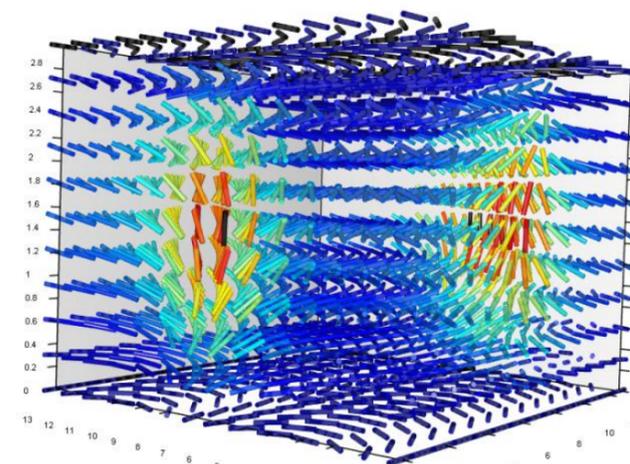
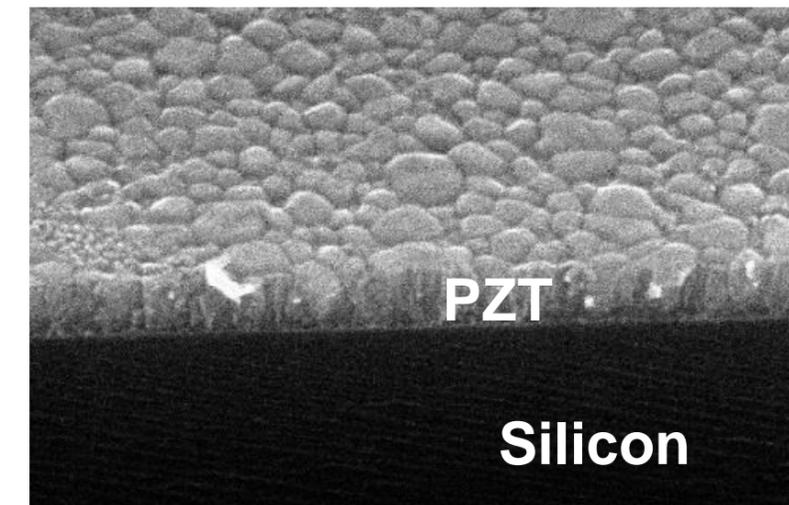
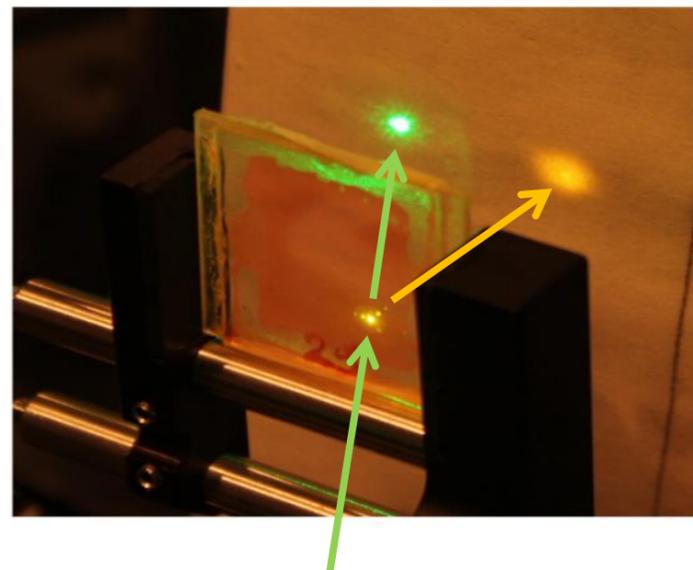


Photo-alignment of LCDs



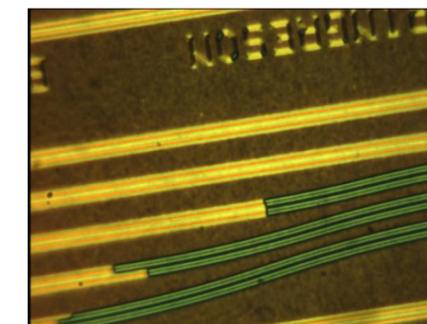
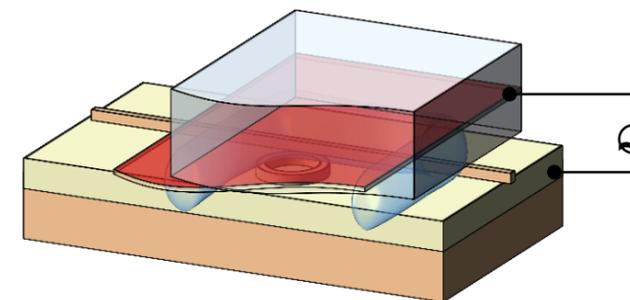
Sol Gel of PZT

LCP - APPLICATION EXAMPLES

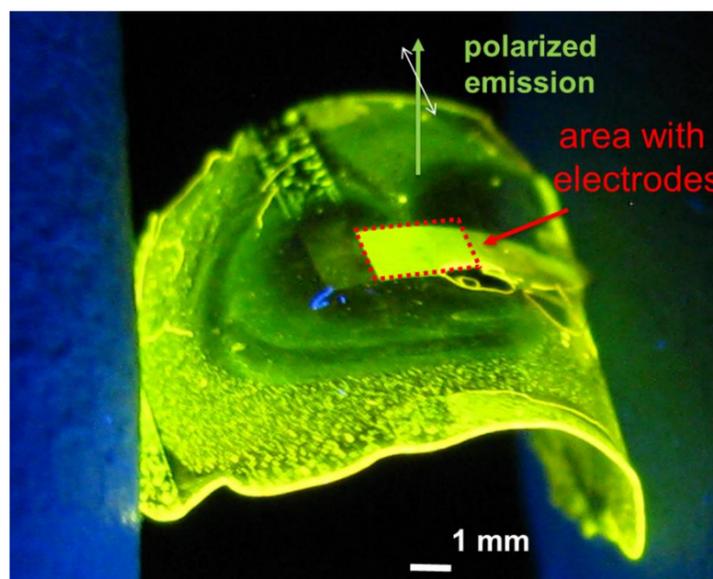


Tunable liquid crystal lasers

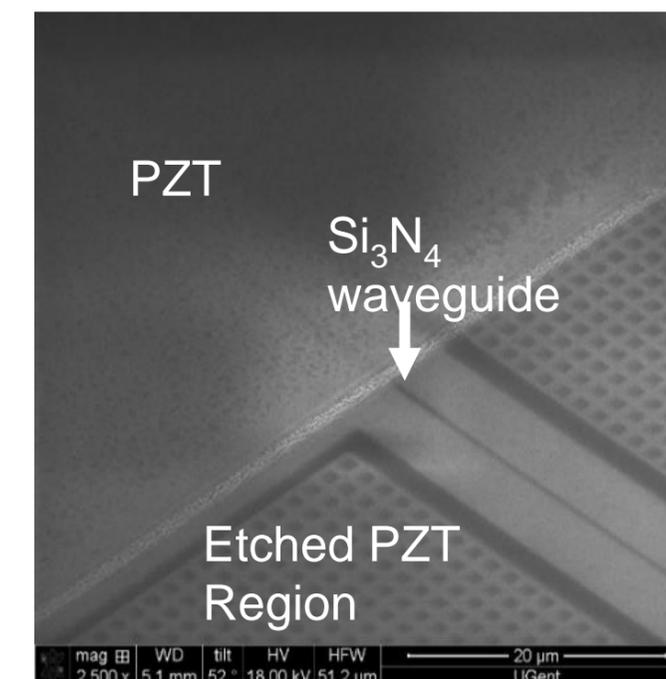
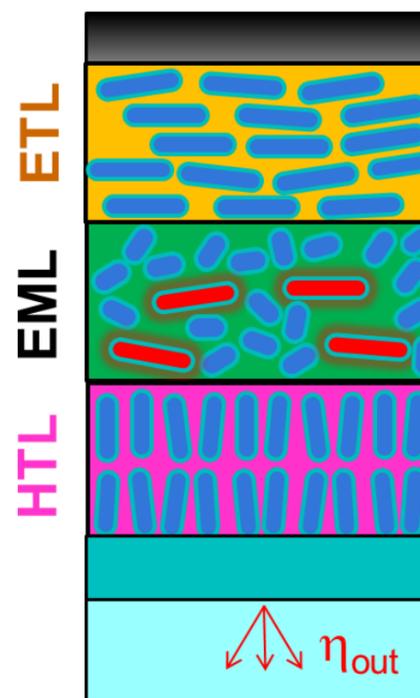
Tunable ring resonators with LC



Anisotropic OLED devices

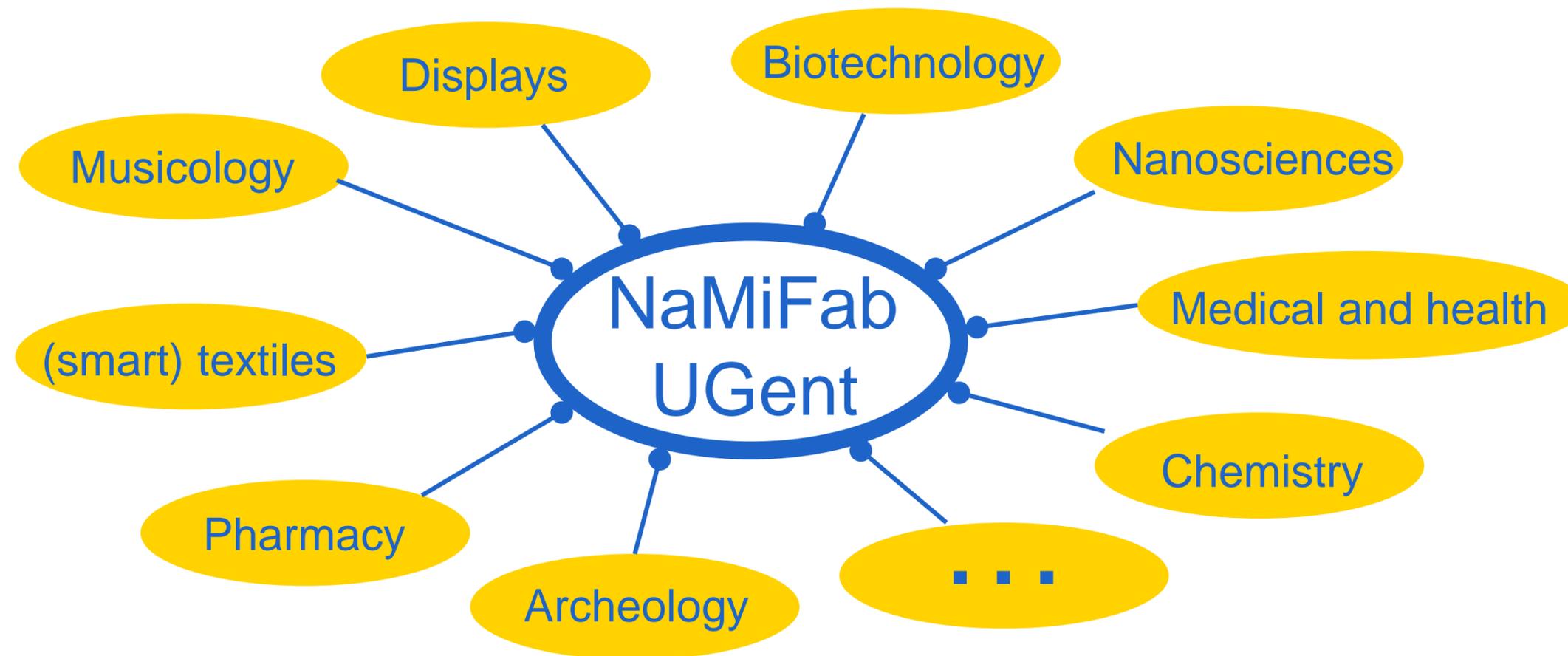


Polarized light emitter



High speed PZT modulators

INTRODUCING NAMIFAB UGENT



Our mission

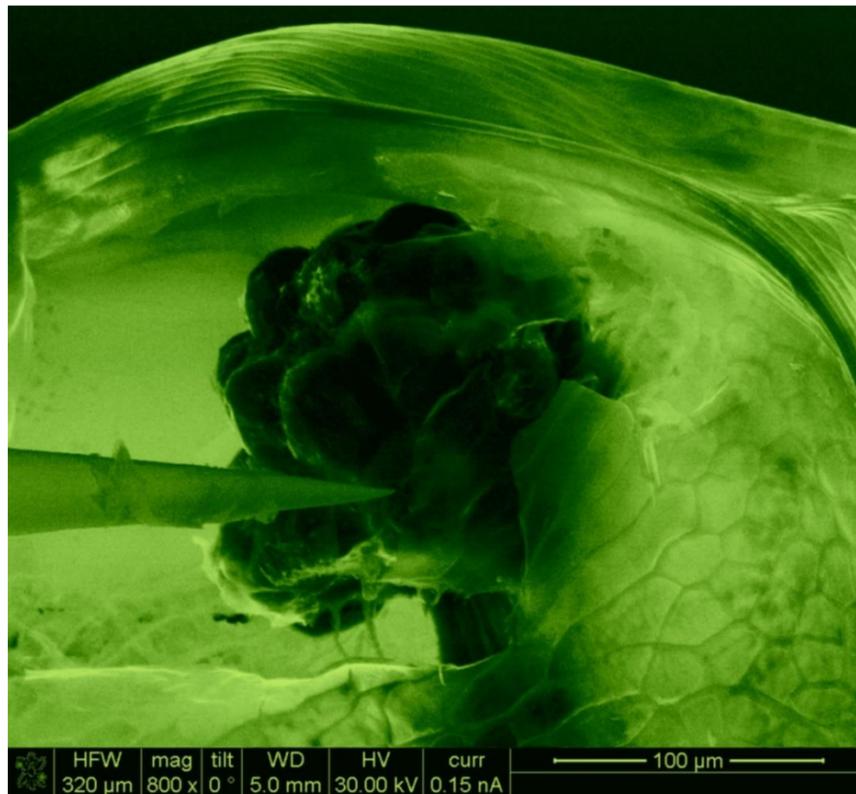
Open up state of the art test and research infrastructure for the entire UGent research community, working in diverse domains.

USE CASE EXAMPLES

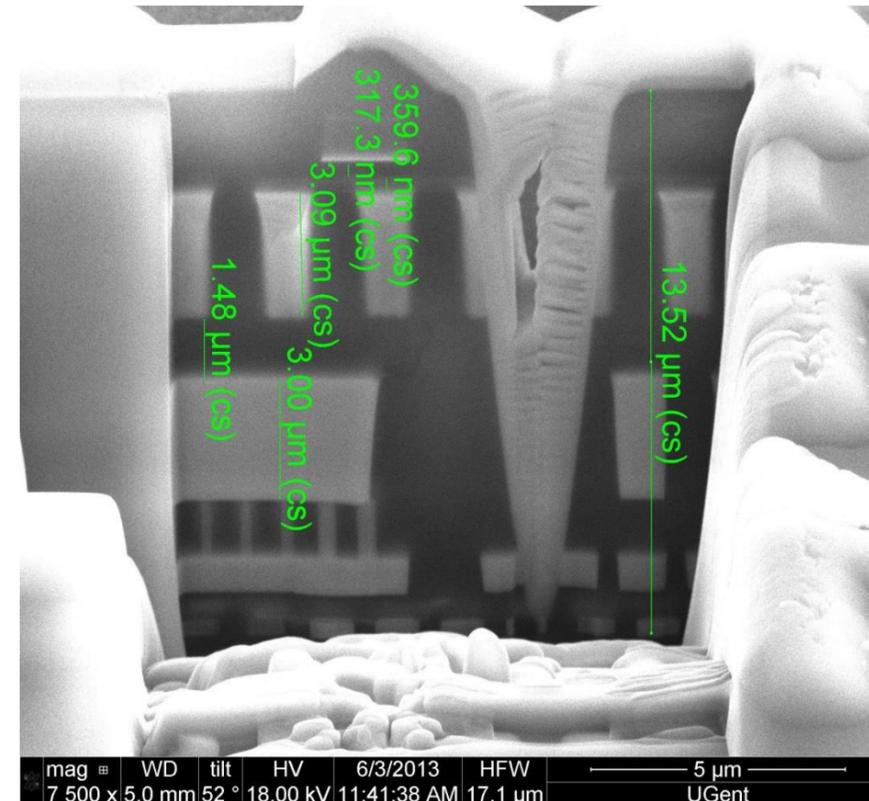
High-Resolution Imaging using Electron Microscopy and Focussed Ion Beam Cross-Sections

→ Nanometer resolution imaging with Electron Microscope

→ Focussed Ion Beam allows to make local cuts to see “into” material



Nanoprobe needle inserted in eye of Daphnia (water flea)



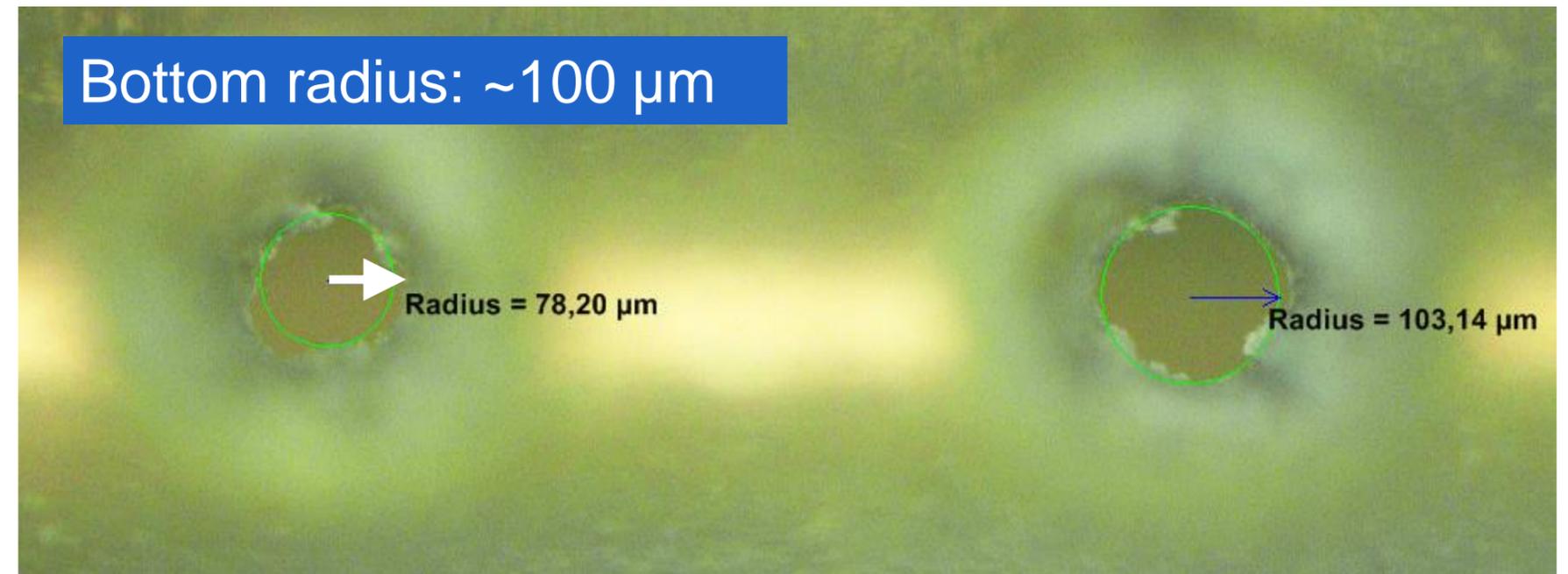
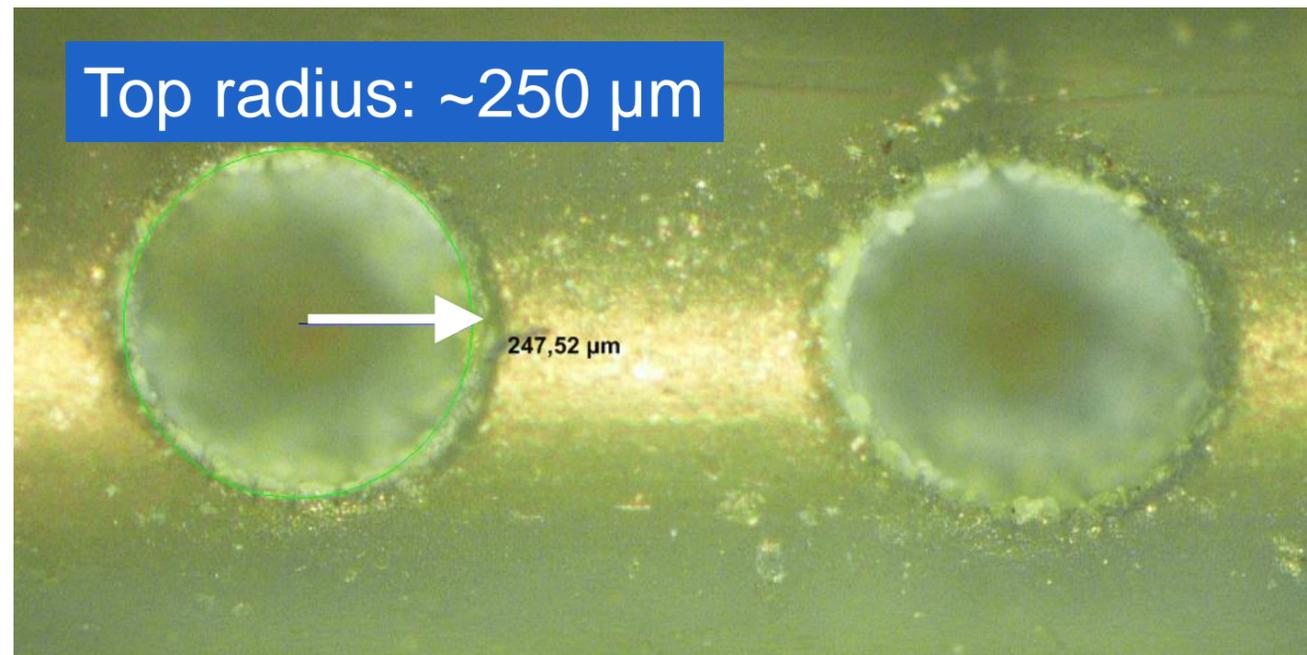
Reverse engineering and correcting mistakes in electronic ICs

USE CASE EXAMPLES

Laser ablation of PDMS catheter for controlled drug release

→ Request from Biofluid, Tissue and Solid Mechanics for Medical Applications group (Prof. Patrick Segers)

- Perforations in a PDMS catheter
(tube inner diameter of ~1mm, 0.4mm thickness)

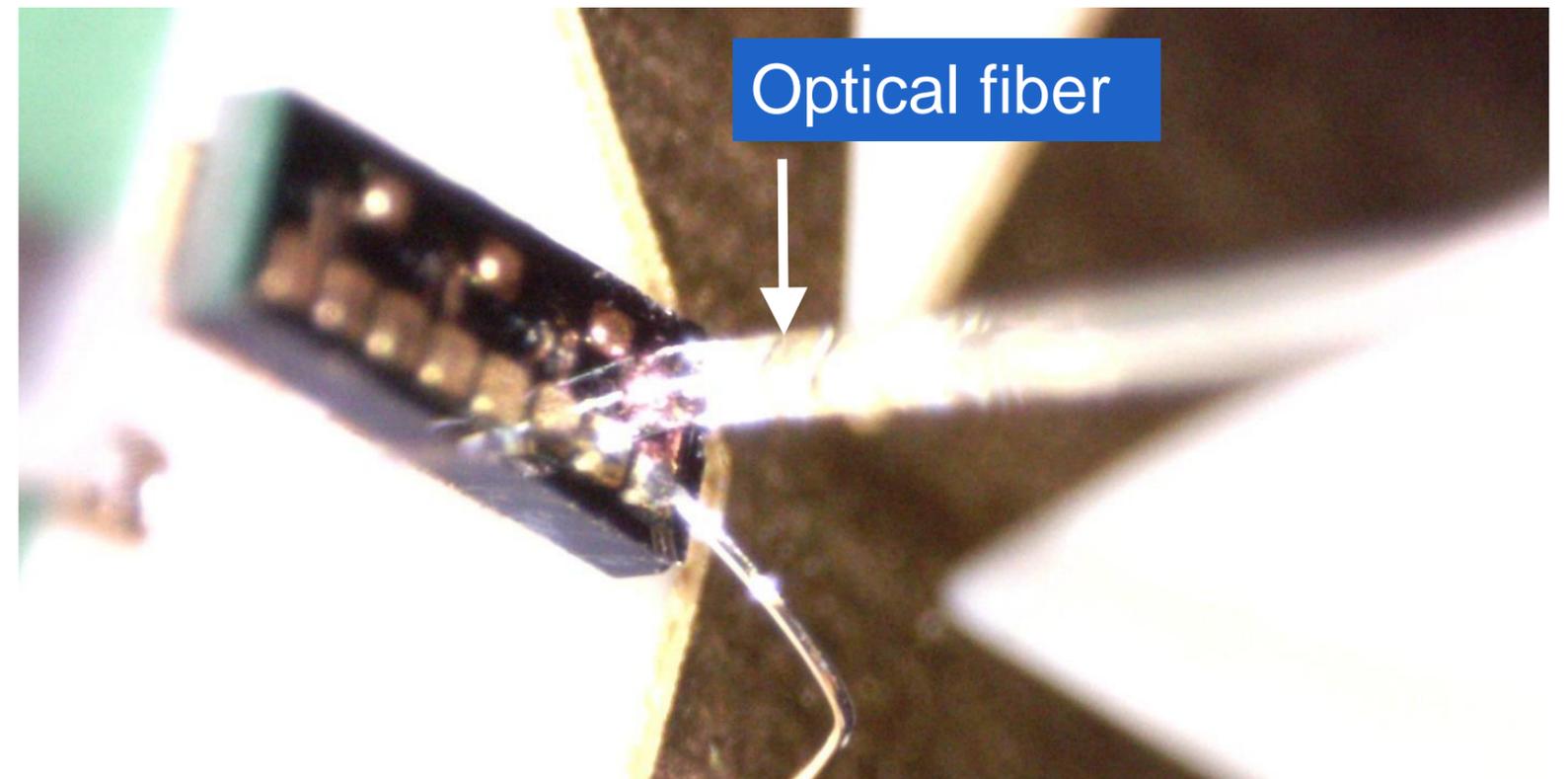
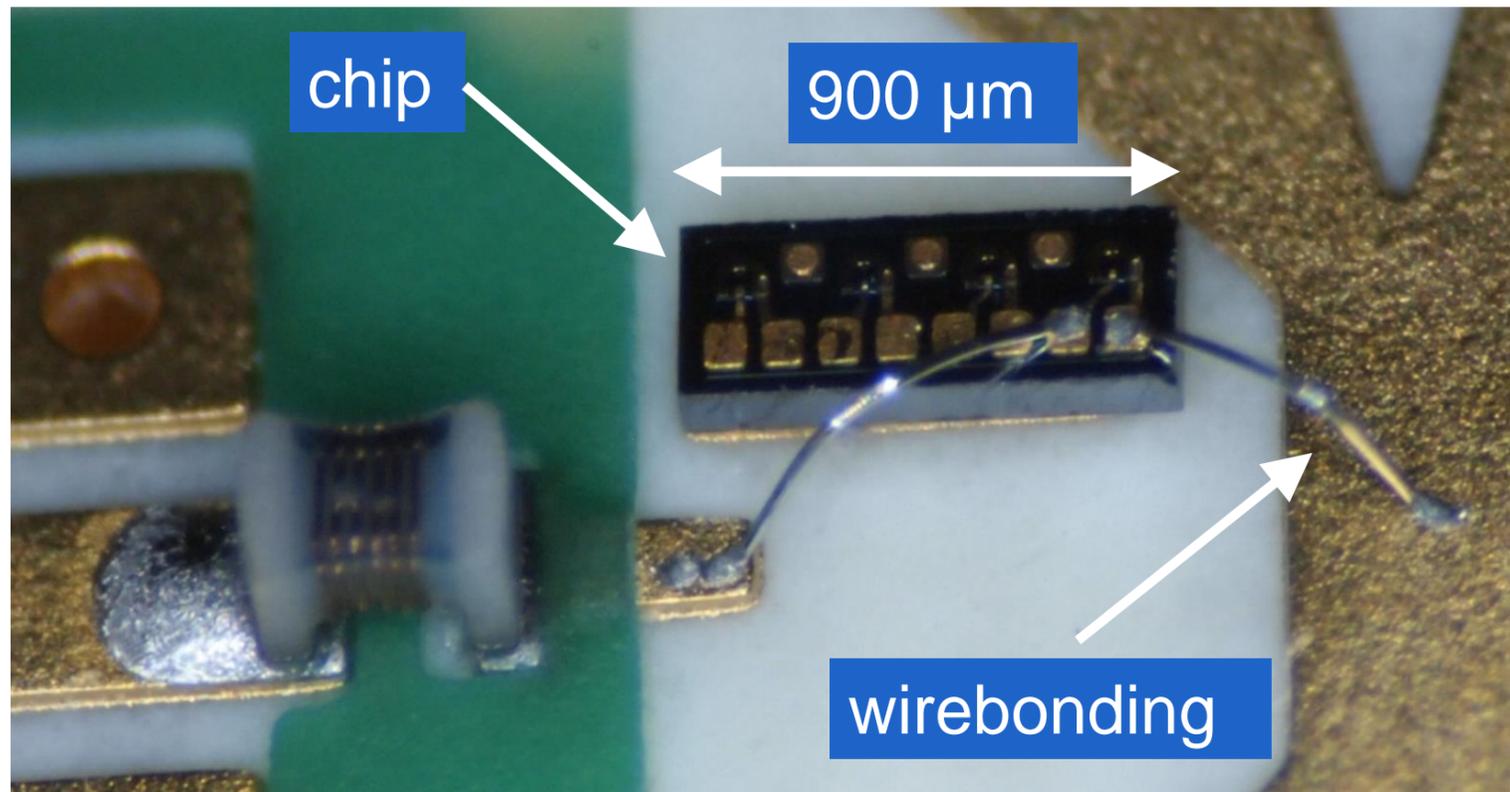


USE CASE EXAMPLES

Wirebonding and pigtailing of a photodiode chip

→ Request from Electromagnetics research group (Prof. Hendrik Rogier)

- Assembly off a photodiode chip onto a PCB
- Optical connection between chip and an optical fiber

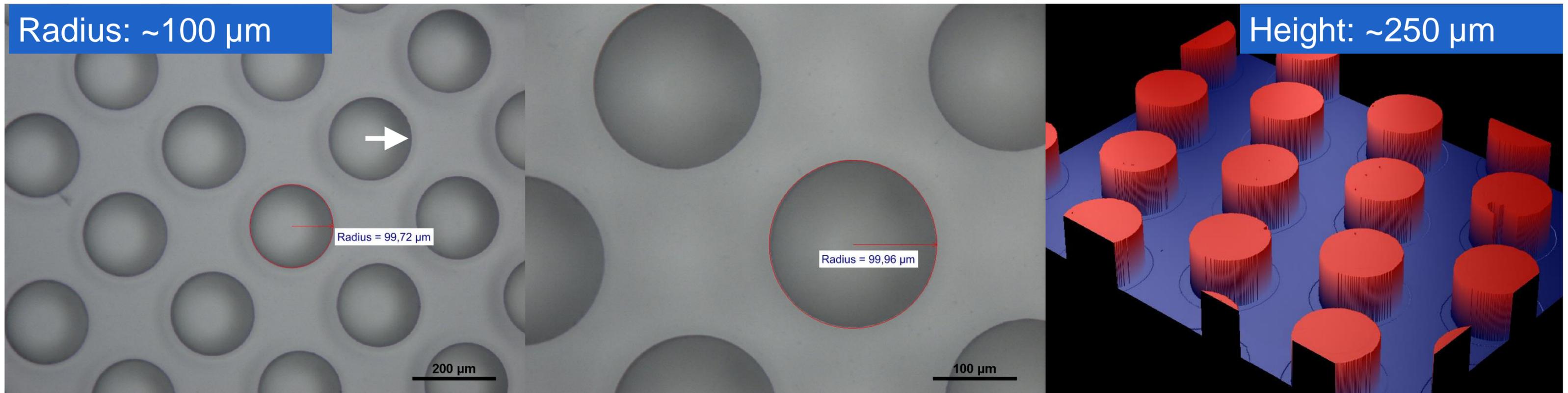


USE CASE EXAMPLES

Fabrication of a microwell-based tissue culture platform

→ Request from Tissue Engineering and Biomaterials research group (Prof. Ria Cornelissen)

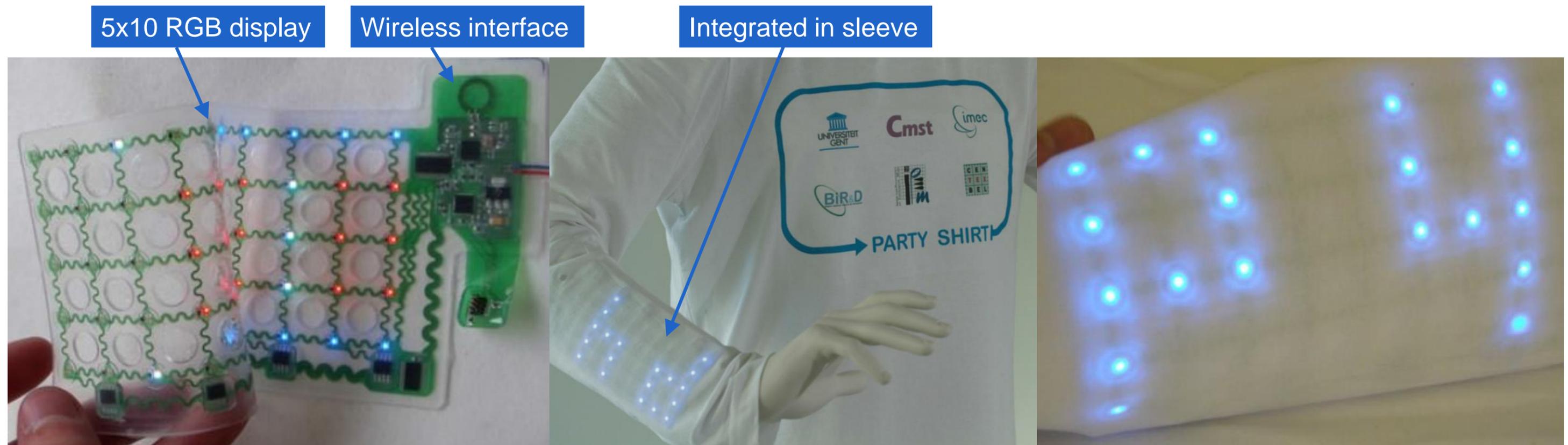
- Fabrication of a PDMS mold to produce a microwell-based tissue culture platform
- The PDMS molds should contain micro-sized cylindrical sticks



USE CASE EXAMPLES

Fabrication of a stretchable and textile integrated LED display

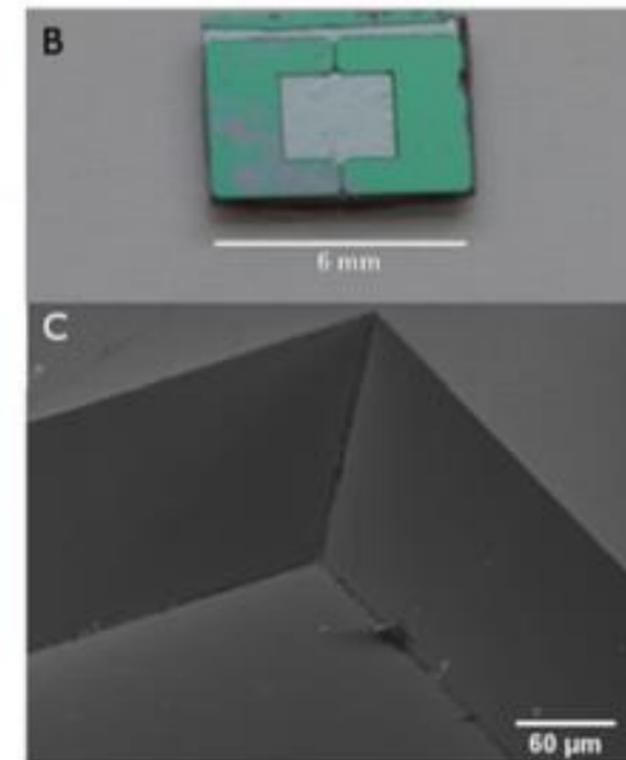
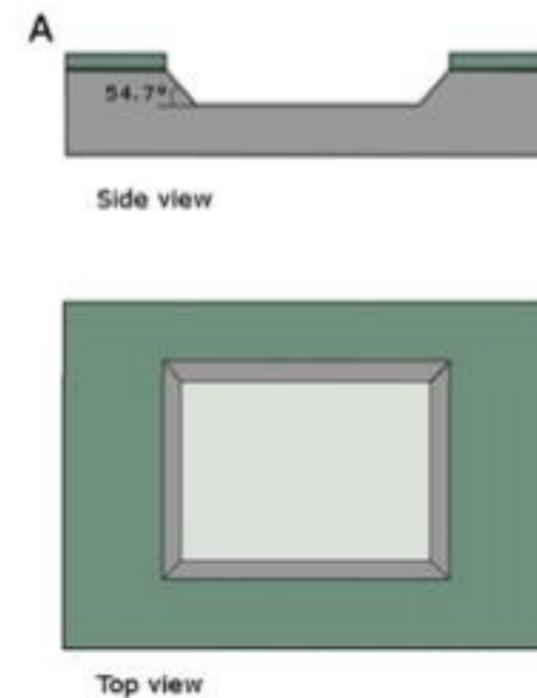
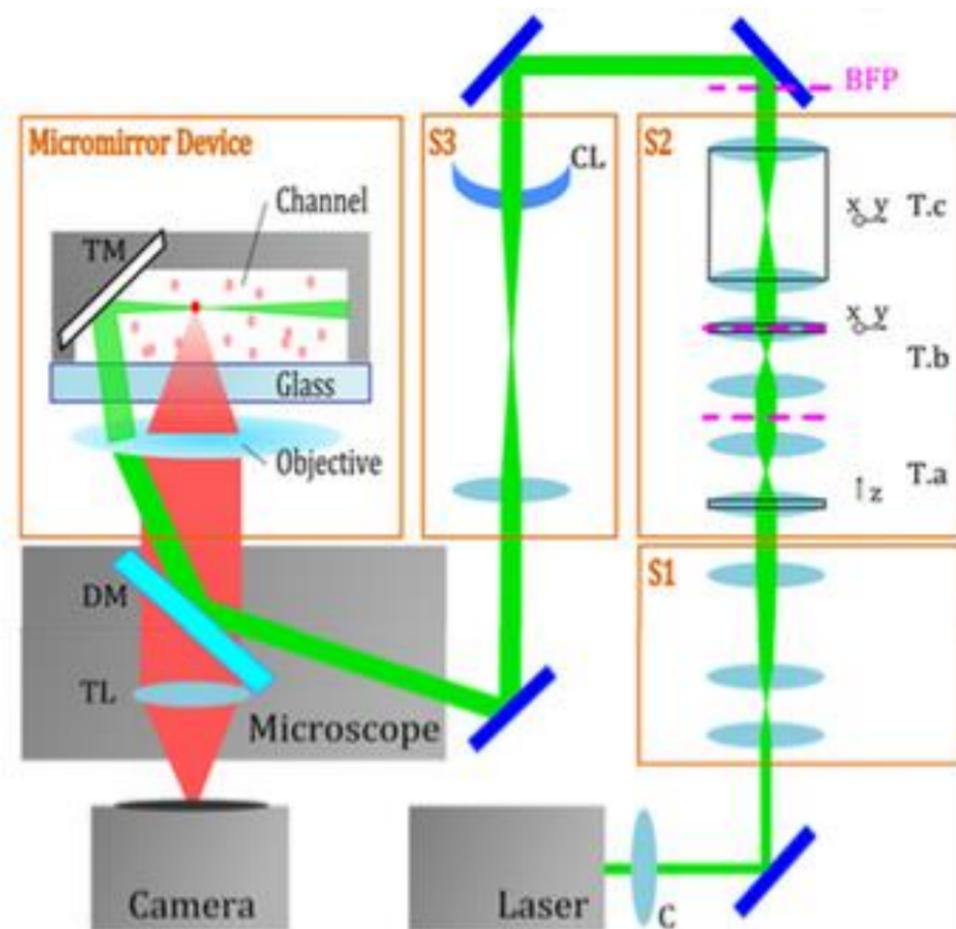
- This was developed in the frame of a BIR&D award winning multidisciplinary master thesis
- The resulting “party shirt” was used by the IPEM institute for systematic musicology (Prof. Marc Leman)



USE CASE EXAMPLES

Silicon microstructure for Light Sheet Microscopy

- Request from Laboratory of General Biochemistry and Physical Pharmacy (Prof. Kevin Braekmans)
- Light Sheet Microscopy gains increasing interest but requires complex optical setup
- **Relatively simple silicon microstructure** overcomes this problem



Silicon microstructure with integrated mirror

NAMIFAB EXPERTISE

- Execution of small exploratory projects, which can form the base for more extended collaborative project proposals
=> create new ideas and opportunities for original interdisciplinary research subjects
- Knowhow and infrastructure for designing, realizing and inspecting nano- and microsystems of very diverse shape, dimensions and complexity

(List of test and research infrastructure on www.ugent.be/namifab/en/infrastructure)



NAMIFAB EXPERTISE

Nano- and microfabrication technologies:

Photolithography (pattern definition)

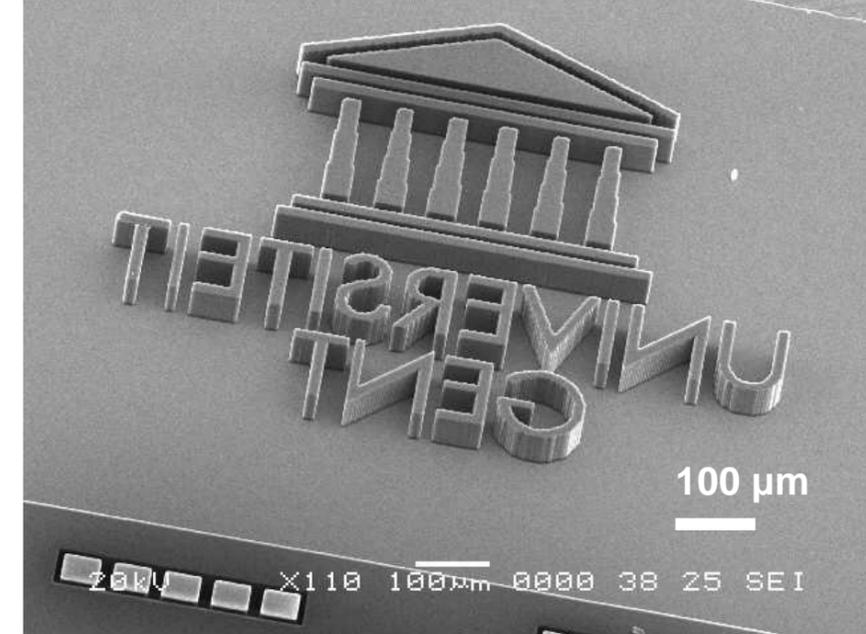
- Photomask alignment and exposure (resolution down to 800nm)
- Laser direct imaging (resolution down to 1 μ m)
- Electron beam lithography (resolution down to 10nm)

Layer deposition

- Spin coating
- Plasma deposition
- Sputter deposition
- Electron beam evaporation
- Thermal evaporation for deposition of organic layers
- Atomic layer deposition (aluminium oxide)

Etching

- Development, etch and strip line for flexible PCBs
- Plasma etching (RIE, ICP, Oxygen)
- HF-vapor etching



Plasma deposition



Thermal evaporation



Flexible PCB processing



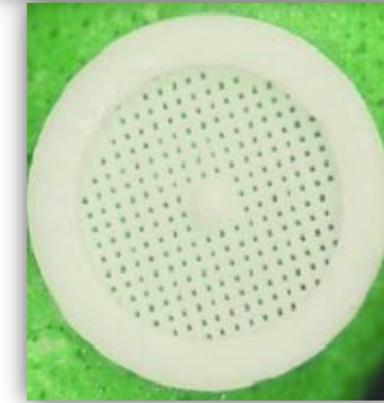
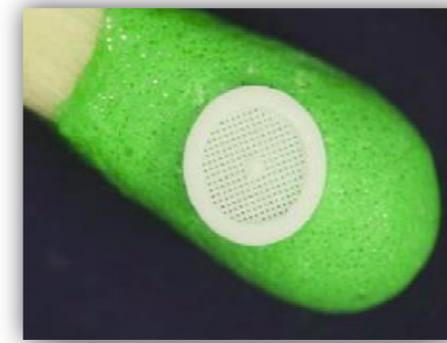
Plasma etching²⁰

NAMIFAB EXPERTISE

Nano- and microfabrication technologies:

Material structuring

- Laser structuring, cutting, drilling and welding on a variety of substrates
- Microinjection moulding of small parts (<1g)
- Dicing, lapping, polishing
- Lamination, imprinting
- Vacuum forming



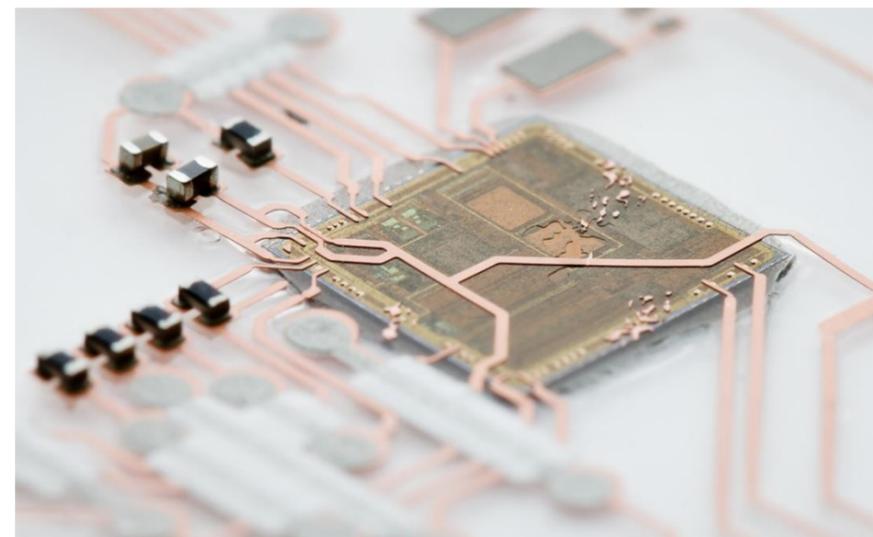
Micromoulding



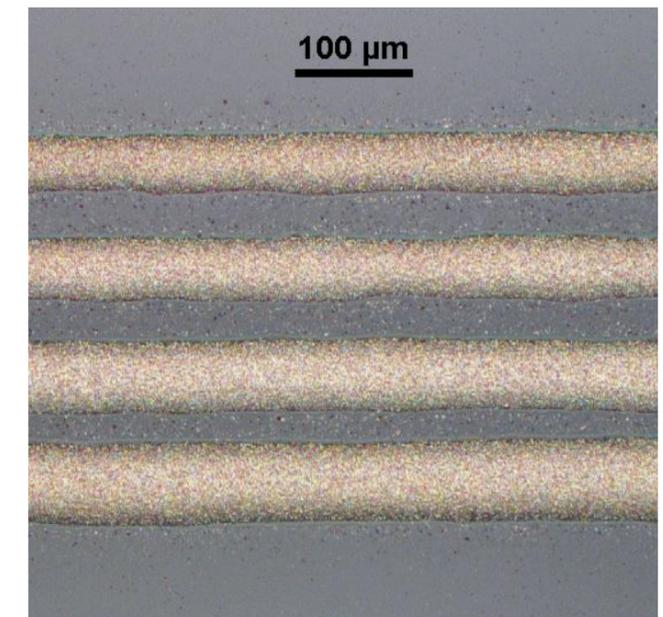
Vacuum forming

Assembly

- Die and flip-chip bonding ($\pm 5\mu\text{m}$ accuracy)
- Accurate ($\pm 1\mu\text{m}$) placement of chips and toher 3D structures
- Micro-Transfer-printing (μTP)
- Wafer bonding
- Automated needle dispensing
- Screenprinting
- Reflow soldering
- Wire bonding
- Aerosol-jet printing (print metallic conductive inks)
- Liquid crystal device assembly



Assembled smart label



Jet printed silver tracks 21

NAMIFAB EXPERTISE

Sample inspection:

Microscopy

- Optical microscopy (mm to μm size features)
- Electron microscopy: SEM, FEG-SEM with in situ FIB
 - Au & C coating for SEM

Profilometry

- 3D optical profilometry
- Step height measurement (stylus 2.5 or 25 μm)

Cross sectioning

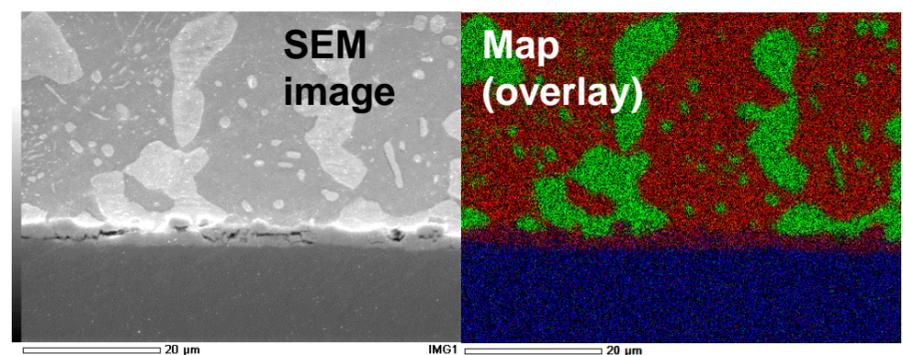
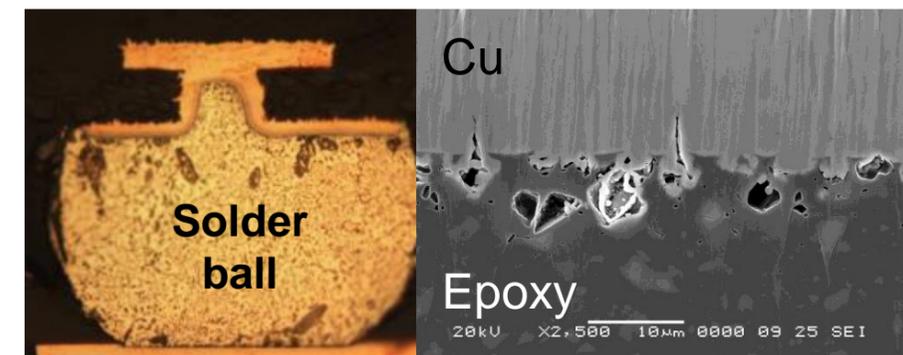
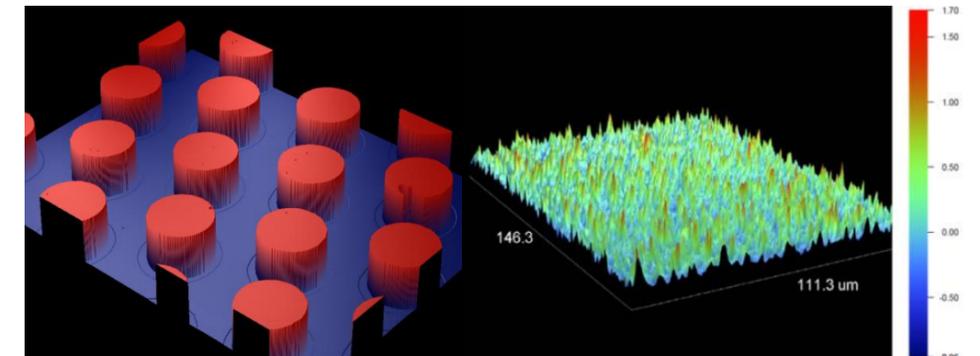
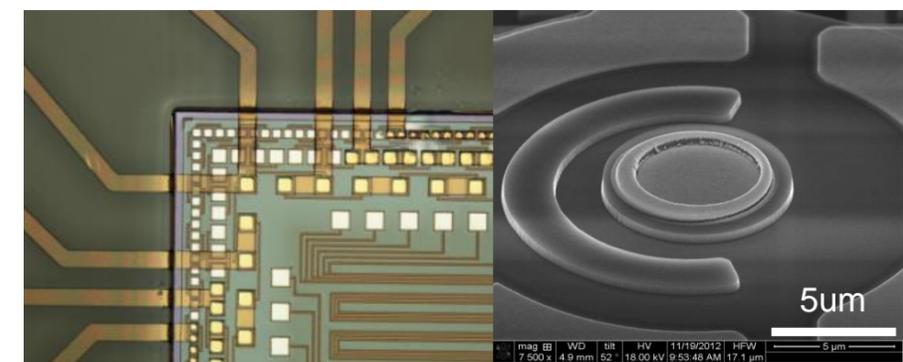
- Sample molding in resins followed by grinding and polishing
- Ion beam polisher
- FIB local cross sections integrated in a FEG SEM instrument

Surface analysis

- Contact angle
- Solderability, Critical Cleanliness Control

Material analysis

- SEM+EDS



NAMIFAB EXPERTISE

Reliability testing and failure analysis:

Mechanical testing

- Peel test (90° & 180°)
- Component shear and pull testing
- Stress/strain measurements
- Standardized washing tests

Climate chamber testing

- Temperature storage (37 - 200 °C)
- Temperature-humidity testing (10 – 95 °C, 10 – 98 % RH)
- Temperature cycling (-70 °C to 180 °C) with in-situ resistance measurement



Universal Testing Machine (INSTRON)



Universal Bond Tester



Humidity testing



Thermal cycling

NAMIFAB EXPERTISE

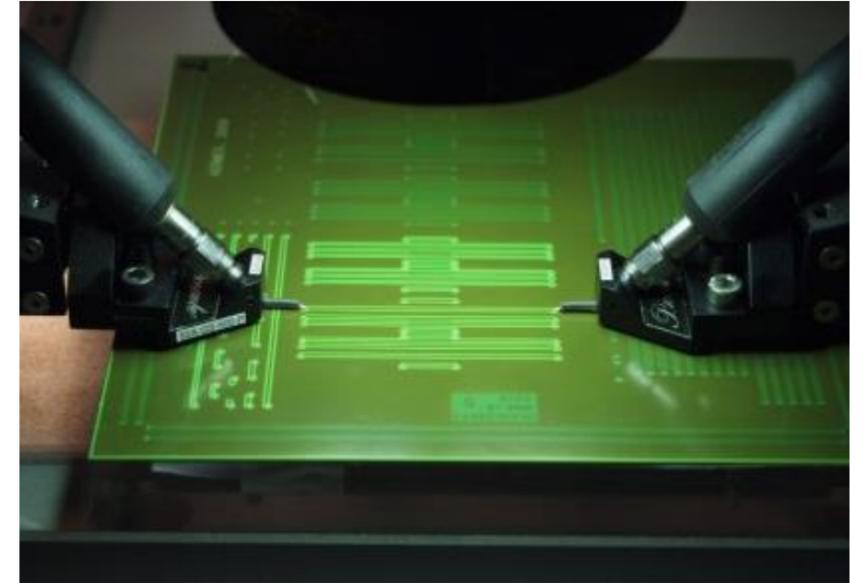
Electrical measurements:

DC measurements

- Contact resistance
- Sheet resistance
- Component characterization (I/V curve, leakage current)
- Surface insulation resistance (linked to climate chamber)

AC measurements

- Electronic circuit analysis
- Impedance and network analysis
- Dielectric withstanding voltage testing up to 6kV



Four-point probe station

COLLABORATION WITH NAMIFAB

Start working with us in three simple steps:

→ File a request

Fill out the NaMiFab request form and send it after completion to thomas.vervust@ugent.be

→ Feedback from NaMiFab

We will contact you to explain what we can do and we will request more input if needed.

→ Execution of the work

Once we both agree on how we will tackle the request, we can start with the actual work.

(Please call or mail if you have questions!)

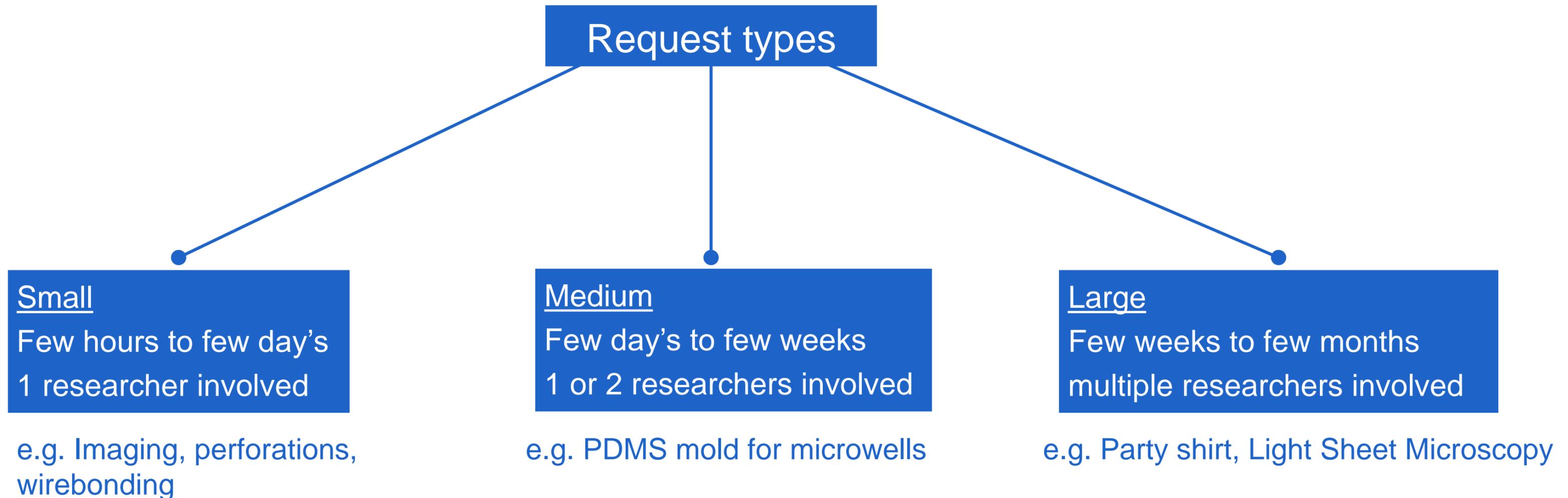
COLLABORATION WITH NAMIFAB

The NaMiFab request form

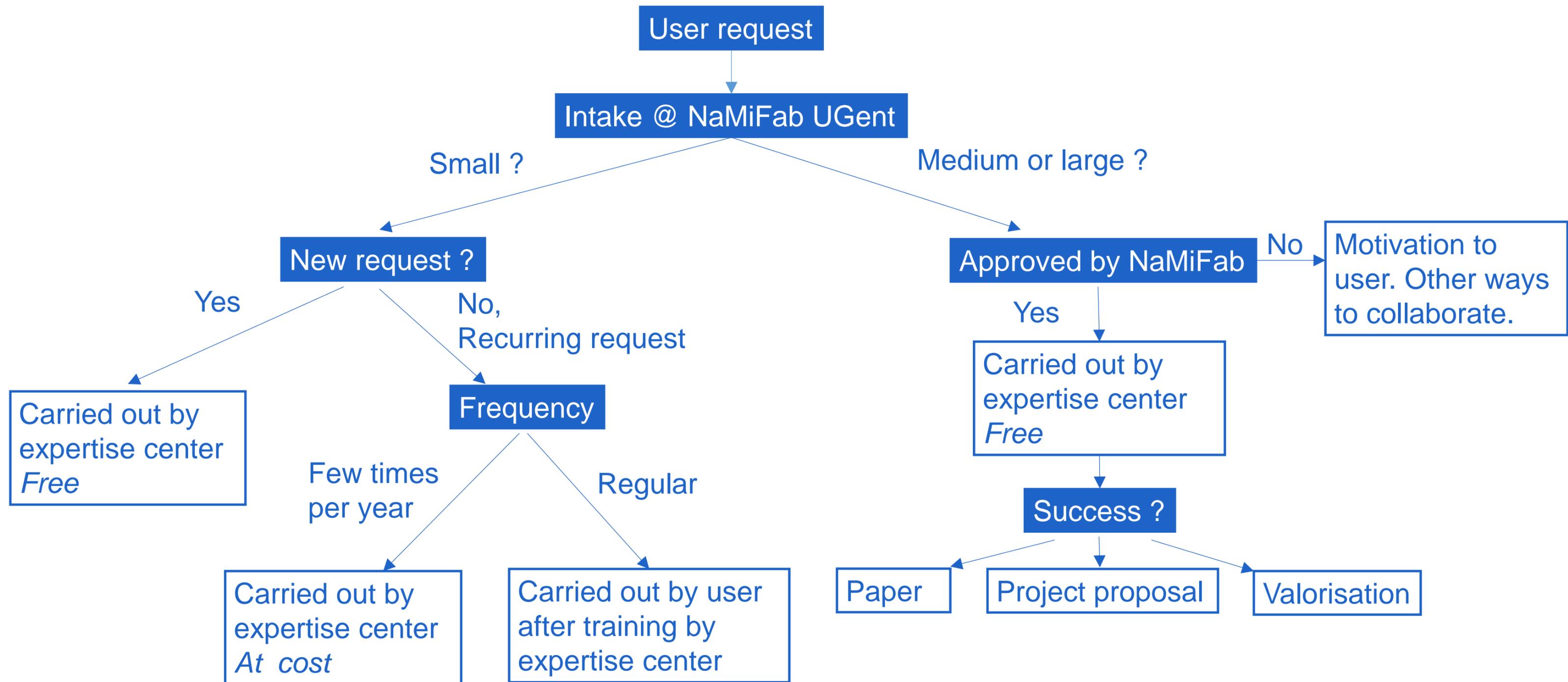
- Can be downloaded from the website (see collaboration page)
- Should be filled out in a clear and concise way (keep it short)
- Provides us information about:
 - Contact details
 - Background of the research
 - The request itself
 - Expectations on the outcome
 - Future plans (additional requests, paper, project proposal,...)

COLLABORATION WITH NAMIFAB

We defined three types of project requests, with different duration and requirements for resources



COLLABORATION WITH NAMIFAB



COLLABORATION WITH NAMIFAB

What's the cost for Ugent research groups?

- The aim of NaMiFab is to **lower the barrier and hence the costs for first entry** as much as possible.
- The target is to accommodate **new requests free of charge** for the user. The user will only be charged in the case of, for example, high consumable costs or special tooling.
- In case of recurring (and hence successful) requests, the user will be requested to carry the costs involved, such as consumables, machine time and operator time (at effective cost).
- Project coordination time will not be charged

dr. ir. Thomas Vervust

Project coordinator

NAMIFAB UGENT

Technologiepark Zwijnaarde 15, 9052 Ghent, Belgium
iGent Tower, Office 160.032 (level 6)

E Thomas.Vervust@ugent.be

T +32 9 264 55 13

www.ugent.be/namifab